Receipt date: 05/23/2011 10573942 - GAU: 1723

Substitute Form PTO-1449			U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		DOCKET NAA237	sn 10/573,942			
Information Disclosure Statement					APPLICANT Akinobu Sato, et al.				
					PILING DATE GROUP				
					March 29, 2006 1723				
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NON-PATENT LITERATURE DOCUMENTS									
*Exam. Initial	Cite No.						TRANSLATION YES NO		
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		Initial if citation considered ered. Include copy of this for				line through citation if not in	conforma	nce	